

INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application No.	10/590,046
		Filing Date	June 15, 2007
		First Named Inventor	Hirayama et al.
		Art Unit	1795
(Multiple sheets used when necessary)		Examiner	Unassigned
SHEET 1 OF 1		Attorney Docket No.	SHIGA7.055APC

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number <i>Number - Kind Code (if known)</i> Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document <i>Country Code-Number-Kind Code</i> Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹

NON PATENT LITERATURE DOCUMENTS						
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				T ¹
	1	YAMAGUCHI et al., <i>Linenwidth fluctuations caused by polymer aggregates in resist films</i> , Journal of Photopolymer Science and Technology, Vol. 10 No. 4, pp. 635-640, (1997)				

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Examiner Signature	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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